

Electronic Patent Application Fee Transmittal

Application Number:	10529152			
Filing Date:	24-Mar-2005			
Title of Invention:	METHOD FOR ETCHING CHROMIUM THIN FILM AND METHOD FOR PRODUCING PHOTOMASK			
First Named Inventor/Applicant Name:	Yasuki Kimura			
Filer:	Kelly G. Hyndman/Robert Price			
Attorney Docket Number:	Q87054			
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Basic Filing:				
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Miscellaneous-Filing:				
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Patent-Appeals-and-Interference:				
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